

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2821**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Hiromi OTOMA

Group Art Unit: 2821

Application No.: 10/826,354

Examiner: C. TRAN

Filed: April 19, 2004

Docket No.: 119498

For: SURFACE EMITTING SEMICONDUCTOR LASER AND COMMUNICATION  
SYSTEM USING THE SAME

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the May 16, 2006 Office Action, please consider the following:

**Amendments to the Specification; and**

**Remarks.**

*is Approved ??  
Please enter  
Thank's  
T. C  
09/08/06*